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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Zarng-Arh George WU, et al.

Appl. No.: 10/785,644

Filed: February 24, 2004

For: METHODS AND COMPOSITIONS

FOR IMPROVED

ELECTROPHORETIC DISPLAY

**PERFORMANCE** 

Art Unit: 1756

Confirmation No. 2380

Examiner: Not Yet Assigned

Atty. Docket: 07783.0063.CPUS02

## **Information Disclosure Statement**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Listed on accompanying Form PTO-1449 are documents that may be considered material to the examination of this application, in compliance with the duty of disclosure requirements of 37 C.F.R. §§ 1.56, 1.97 and 1.98.

Where the publication date of a listed document does not provide a month of publication, the year of publication of the listed document is sufficiently earlier than the effective U.S. filing date and any foreign priority date so that the month of publication is not in issue. Applicants have listed publication dates on the attached PTO-1449 based on information presently available to the undersigned. However, the listed publication dates should not be construed as an admission that the information was actually published on the date indicated.

Applicants reserve the right to establish the patentability of the claimed invention over any of the information provided herewith, and/or to prove that this information may not be prior art, and/or to prove that this information may not be enabling for the teachings purportedly offered.

This statement should not be construed as a representation that a search has been made, or that information more material to the examination of the present patent application does not exist. The Examiner is specifically requested not to rely solely on the material submitted herewith. It is further understood that the Examiner will consider information that had been cited by or submitted to the U.S. Patent and Trademark Office in a prior application relied on under 35 U.S.C. § 120. 1138 OG 37, 38 (May 19, 1992).

Applicants have checked the appropriate boxes below.

- 1. This Information Disclosure Statement is being filed;
  - □ a. Within three months of the U.S. filing date of a national application other than a continued prosecution application under §1.53(d);
  - □ b. Within three months of the date of entry of the national stage as set forth in §1.491 in an international application;
  - c. Before the mailing date of a first Office Action on the merits;
  - □ d. Before the mailing of a first Office Action after filing of a request for continued examination under § 1.115.

No statement under 37 C.F.R. § 1.97(e) or fee is required.

or;

- □ 2. This Information Disclosure Statement is being filed after the period specified in paragraph 1(a)-1(d) above, but before the mailing date of a Final Rejection or Notice of Allowance, or action that otherwise closes prosecution in the application, and
  - □ a. I hereby state that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 C.F.R. § 1.97(e)(1), or

	⊔ b.	I hereby state that no item of information in this Information Disclosure				
		Statement was cited in a communication from a foreign patent				
		office in a counterpart foreign application, and, to my knowledge				
		after making reasonable inquiry, no item of information contained				
		in this Information Disclosure Statement was known to any				
		individual designated in 37 C.F.R. § 1.56(c) more than three				
		months prior to the filing of this Information Disclosure Statement.				
		37 C.F.R. § 1.97(e)(2), or				
	□ c.	Attached is our Check No in the amount of \$ in				
		payment of the fee under 37 C.F.R. § 1.17(p).				
□ 3.	This I	nformation Disclosure Statement is being filed more than three months after				
		the U.S. filing date and after the mailing date of a Final Rejection or				
	Notice of Allowance, but on or before payment of the Issue Fee.					
		is our Check No in the amount of \$ in payment of the				
		fee under 37 C.F.R. § 1.17(i), and				
	□ a.	I hereby state that each item of information contained in this Information				
		Disclosure Statement was first cited in any communication from a				
		foreign patent office in a counterpart foreign application not more				
		than three months prior to the filing of this Information Disclosure				
		Statement. 37 C.F.R. § 1.97(e)(1), or				
	□ b.	I hereby state that no item of information in this Information Disclosure				
		Statement was cited in a communication from a foreign patent				
		office in a counterpart foreign application, and, to my knowledge				
		after making reasonable inquiry, no item of information contained				
		in this Information Disclosure Statement was known to any				
		individual designated in 37 C.F.R. § 1.56(c) more than three				
		months prior to the filing of this Information Disclosure Statement.				

37 C.F.R. § 1.97(e)(2).

specification.

Relevance of the non-English language document(s) is discussed in the present

□ 4.

- 4 - Attorney Docket No. 07783.0063.CPUS02 Appl. No. 10/785,644

□ 5. ´	The document(s) was/were cited in	a corresponding foreign application. An			
	English language version of t	he foreign search report is attached for the			
	Examiner's information.				
□ 6. <i>A</i>	A concise explanation of the relevance	ce of the non-English language document(s)			
	appears below:				
□ 7.	The Examiner's attention is directed	to co-pending U.S. Patent Application No.			
	, filed,	which is directed to related technical subject			
	matter. The identification of	f this U.S. Patent Application is not to be			
	construed as a waiver of se	crecy as to that application now or upon			
	issuance of the present app	olication as a patent. The Examiner is			
	respectfully requested to cons	sider the cited application and the art cited			
	therein during examination.				
□ 8. <b>(</b>	Copies of the documents were cited b	by or submitted to the Office in Application			
	No, filed	, which is relied upon for an earlier			
	filing date under 35 U.S.C. §	120. Thus, copies of these documents are			
	not attached. 37 C.F.R. § 1.98(	(d).			
I	It is respectfully requested that the Exa	aminer initial and return a copy of the			
enclosed	d PTO-1449, and to indicate in the off	icial file wrapper of this patent application			
that the	documents have been considered.				
7	The U.S. Patent and Trademark Office	e is hereby authorized to charge any fee			
deficien	ncy, or credit any overpayment, to our	Deposit Account No. 08-3038 referencing			
docket n	number 07783.0063.CPUS02.	,			
	7				
	1	Respectfully submitted,			
Date: November 1, 2005  Viola T. Kung (Reg. No. 41,131)					
	7	Viola T. Kung (Reg. No. 41,131)			
	REY LLP airview Park Drive				

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## ONFORMATION DISCLOSURE

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ATTY. DOCKET NO. 07783.0063.CPUS02 SERIAL NO.

10/785,644

APPLICANT: Zarng-Arh George WU, et al.

FILING DATE: 2/23/2004

GROUP:1756

PAR THAD BUR	A CONTRACTOR OF THE PARTY OF TH	l l	FILING DATE :   2/23/2004		GROUP :1756					
		U.S. P	ATENT DOCUMENTS	S	-					
EX'R INITIAL	PATENT NO.	DATE MM-YYYY	NAME	CLASS	SUBCLASS	FILIN	G DATE			
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	5,930,026	07-1999	Jacobson, et al							
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	6,933,098	12-2002	Chan-Park, et al							
		FOREIG	N PATENT DOCUMEN	Te		<u> </u>	<del></del> .			
EX'R	PATENT NO. DATE		COUNTRY	CLASS	SUBCLASS	TRANSLATION				
INITIAL		MM-YYYY		į		YES	NO			
	EP 0 615 164 A	09-1994	Europe							
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	Chung, J., Hou, J., Wang, W., Chu, L.Y., Yao, W., & Liang, R.C. (2003, December). Microcup(R) Electrophoretic Displays, Grayscale and Color Rendition. <i>IDW</i> , AMD2/EP1-2, 243-246.
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	Zang, H.M., & Liang, R.C. (2003) Microcup Electronic Paper by Roll-to-Roll Manufacturing Processes. <i>The Spectrum</i> , 16(2), 16-21.
EXAMINER	DATE CONSIDERED:
EYAMINED.	Initial if situation considered subother or not the situation confirmed the APPR CO. D

EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

applicant.

\*If an asterisk is placed beside the reference number, a copy is not provided because the reference was previously cited by or submitted to the PTO in a prior application that is identical in the statement and relied upon for an earlier